Short Polarization Filter in Pillar-Based Photonic Crystals

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Abstract—The strong polarization dependence of two-dimensional photonic crystals is exploited for polarization filtering. The device with a length of 3.9 μm is integrated in a photonic integrated circuit based on InP waveguide technology. The average transmissions in the wavelength range from 1530 to 1570 nm are -8.7 dB for transverse-magnetic polarization and -26.5 dB for transverse-electric polarization.

Index Terms—Optical waveguide components, photonic crystals, polarization.

I. INTRODUCTION

TWO-DIMENSIONAL (2-D) photonic crystals (PhCs) have been subject to extensive research in the past years, offering a huge potential for integration in photonic integrated circuits. They can be used to miniaturize existing integrated optical devices, e.g., bends, microcavities, add-drop filters, and band edge lasers. Furthermore, their special properties can be used to design devices based on new principles. An example of such a device is a polarization filter. The polarization sensitivity of PhCs makes it possible to significantly reduce the footprint of polarization filters.

Photonic integrated circuits can be realized in different material systems, depending on the applications. However, indium phosphide (InP) technology is the only platform to monolithically integrate active and passive devices for use in the telecom wavelength window (1530–1570 nm). The classical waveguides of InP photonic integrated circuits are based on total internal reflection; light is confined to the indium gallium arsenide phosphide (InGaAsP) core, which has a higher refractive index than the InP cladding layers (nInGaAsP ≈ 3.3610 and nInP ≈ 3.1603 at a wavelength of 1550 nm [1]). In 2-D PhCs, the in-plane confinement is created by the photonic bandgap properties of the crystal, whereas the light is mainly confined out-of-plane by total internal reflection in the semiconductor layer stack.

In photonic integrated circuits for telecommunication networks, polarization control is of increasing importance [2]. This control is obtained by the integration of polarization splitters, converters, and filters in the photonic circuit. Polarization splitters based on classical waveguide technology are relatively long devices, in the order of millimeters [3], [4]. The highly polarization-dependent nature of PhCs enables the use of them in short polarization splitters, significantly reducing their size [5]–[7]. However, if only a filtering function is needed, the use of relatively long and complicated polarization splitters can be avoided. In this work, the strong polarization dependence of 2-D PhCs ([8]) is used to investigate a transverse-electric (TE) polarization filter based on a pillar PhC waveguide in a square lattice of high-index pillars. Transverse-magnetic (TM)-polarized light is defined as the polarization that has its electric field vector parallel to the pillars, and TE-polarization has its electric field vector in the plane of the chip. The device is integrated in a classical photonic integrated circuit on an InP substrate with a 500-nm-thick InGaAsP core layer and a 1-μm-thick InP top cladding. The layer stack of the pillar PhC is compatible with that of the classical photonic integrated circuit, and so is the fabrication technology.

II. DESIGN OF THE TE FILTER

A waveguide based on a line defect in a pillar PhC can serve as a TE filter if the TE polarized light does not couple into the PhC waveguide (either if this waveguide has a TE bandgap or if the coupling efficiency for TE is very small) or if the TE polarized light is not confined by the crystal, in which case it radiates away from the line defect. In this letter, we aim for the design and realization of a PhC waveguide with a high transmission for TM polarization, and a very small coupling efficiency for TE polarization due to a large impedance mismatch. Therefore, the line defect was first optimized for TM transmission, as the transmission of TM polarized light should be high.

Based on 2-D band solver calculations, and using the effective index method to account for the third dimension, the background PhC was chosen to have a lattice constant a = 491 nm and a radius r = 0.25a. The introduction of a line defect of larger pillars along the ΓX-direction creates two guided TM modes inside the bandgap of the PhC. Fig. 1 shows the projected band diagram of a PhC waveguide based on a line defect with radius ra = 210 nm. The mode that increases in frequency, having a positive slope, is a mode with odd symmetry. The mode with a negative slope is a mode with even symmetry. At the wavelength of operation, i.e., in the range from 1530 to 1570 nm, the waveguide only supports the even symmetry mode.

The light is coupled from a conventional ridge waveguide to the PhC waveguide and vice versa by placing the waveguides next to each other as is schematically shown in Fig. 2. The ridge
waveguide is first adiabatically tapered down to a width that is equal to the diameter of the defect pillars, i.e., 420 nm. According to simulations, the transmission for TM polarized light is highest if the gap between the end facet of the ridge waveguide and the first PhC pillar is taken to be 36 nm.

In Fig. 3, the calculated transmission is shown for a PhC waveguide that is eight periods long (based on a three-dimensional (3-D) finite-difference time-domain calculation). The transmission for TM polarized light is 2.3 dB with an extinction ratio better than 25 dB around λ = 1550 nm. The good performance of this device is mainly due to a high coupling efficiency of the TM polarization at the transitions between the ridge waveguides and the PhC waveguide, while the TE polarization has a poor coupling from the access ridge waveguide to the PhC waveguide. The length of the polarization filter is only 3.9 μm (eight times the lattice constant).

The optical circuit design, as schematically shown in Fig. 2, on the chip consisting of a 2-μm-wide input ridge waveguide, followed by a 1 × 2 multimode interference (MMI) coupler splitting the light into two branches. Because of the symmetry of this device, both output arms receive equal optical powers, even if the dimensions deviate from the design parameters. In the reference branch, the light propagates through a conventional ridge waveguide towards the output side of the chip. The other branch contains a PhC waveguide. This configuration has two advantages. First, the coupling alignment into the input waveguide can easily be optimized using the reference arm. Second, the transmission of the PhC waveguide can directly be calculated from a comparison with the transmission of the reference arm.

III. FABRICATION

The ridge waveguides and the MMIs are defined by optical lithography, whereas the PhCs are defined by electron beam lithography to have sufficient control over the critical dimensions. At the transition between the optically defined waveguides and the e-beam lithography areas, the waveguides are 0.8 μm wide. The e-beam lithography section includes the 0.8-μm waveguide of the upper arm to account the transition effect between the optically defined section and the e-beam defined section. The alignment accuracy of the e-beam lithography is better than 50 nm. The waveguide pattern, including the PhCs, is first defined in a 50-nm-thick chromium masking layer by a series of lithography steps. This pattern is transferred into a 430-nm-thick silicon dioxide layer by reactive ion etching (RIE) using a CHF₃ chemistry. Finally, the deep etch to create the waveguides is performed by inductively coupled plasma (ICP) RIE using a Cl₂ : Ar : H₂ chemistry [9]. Fig. 4 shows a scanning electron microscope (SEM) image of the PhC structure after the ICP etch. The pillars are 3.0 μm deep. According to simulations, this should be enough to prevent the light from coupling to the substrate modes [10].

IV. TRANSMISSION MEASUREMENTS

Light from a tunable laser source is coupled into the input waveguide using a microscope objective. The polarization is fixed to TM or TE by use of a polarizer. At the output side, the transmitted light is collected with a lensed fiber. The collected light is measured by a photoreceiver. After optimization of the in- and outcoupling alignment at λ = 1550 nm, the tunable laser scans the wavelength from 1530 to 1570 nm in steps of 0.1 nm.

The cleaved facets of the chip introduce Fabry–Pérot fringes on the measured spectrum. These are averaged out by taking a running average over ten data points of the spectrum. From the
Fig. 4. SEM image of a cross section of a PhC waveguide connected to a classical ridge waveguide on an InP substrate. In the characterized devices, the silicon dioxide mask layer was removed before the transmission measurements were carried out.

Fig. 5. Measured transmission of a fabricated TE filter for both polarizations. The length of the PhC waveguide is eight periods (3.9 μm).

averaged spectra of both the branches, the transmission of the PhC waveguide is determined. The transmission losses include the tapering of a waveguide from 0.8-μm width down to the diameter of the defect pillars, the coupling to and from the PhC waveguide, and the propagation loss of the PhC waveguide.

The measured transmission for both TM and TE polarization is shown in Fig. 5. The average transmission for TM polarized light is −8.7 dB. The losses are higher than was calculated in the 3-D simulation. Previous results show that coupling losses of the PhC polarization are negligible with respect to the propagation losses of the PhC waveguides [11]. The high propagation loss is probably due to scattering and to the nonvertical sidewalls of the pillars, which can cause large substrate leakage. Both can be reduced by an optimization of the fabrication technology. The TE transmission is −26.5 dB, which is in agreement with the simulated transmission. The modulation on the transmission of the TE polarization corresponds to a Fabry–Pérot cavity between the transition at the edge of the e-beam write field (where the e-beam lithography is aligned to the optical lithography) and the PhC waveguide. The reflection at the input of the PhC waveguide is due to the high impedance mismatch for TE polarization. The reflections at the edges of the e-beam write field can be eliminated by adapting the design of the chip. This implies that an extinction ratio of about 18 dB should be feasible if the reflections are reduced.

V. Conclusion

A very short TE polarization filter can be realized in a pillar PhC. The fabrication process is compatible with that of a photonic integrated circuit based on conventional waveguide technology. The device with a length of 3.9 μm has a transmission of −8.7 dB for TM polarization and −26.5 dB for TE polarization. The high losses are probably due to fabrication issues which can be solved by further optimization of the technology. The device, based on a simple design concept, can be used to define the state of polarization in a photonic integrated circuit, improving its stability and performance.

REFERENCES